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INFORMATION DISCLOSURE STATEMENTO BY APPLICANT

(Use several sheets if necessary)

Applicants
Ben-Menachem et al.

Filing Date September 22, 2003 Group Art Unit Not Yet Assigned

DESERTENT DOCUMENTS

Exam. Init.	Document No.							Date	Name	Class	Subclass	Filing Date
4	6	1	2	2	9	9	9	09/26/00	Durazo et al.	82	1.11	
	5	9	6	9	8	6	4	10/19/99	Chen et al.	359	569	
	5	9	1	4	8	2	1	06/22/99	Chen et al.	359	711	
	5	7	3	8	1	6	5	04/14/98	Imai	165	80.2	
	5	7	2	6	7	9	9	03/10/98	Abe et al.	359	431	
T	5	7	1	5	0	3	1	02/03/98	Roffman et al.	351	161	
	5	6	8	9	3	7	3	11/18/97	Takato	359	646	
	5	6	6	8	6	7	1	09/16/97	Erdmann	359	716	
	5	6	4	2	2	2	9	06/24/97	Kaneko et al.	359	649	
	5	6	3	8	2	1	2	06/10/97	Meyers et al.	359	569	
	5	6	1	6	0	5	1	04/01/97	Rogers et al.	439	518	
	5	6	1	5	0	5	1	03/25/97	Takato	359	790	
	5	5	8	3	6	9	8	12/10/96	Yamada et al.	359	687	
	5	4	7	5	5	3	7	12/12/95	Kobayashi et al.	359	794	
	5	3	8	6	3	1	5	01/31/95	Amon et al.	359	350	
	5	3	6	5	3	7	7	11/15/94	Sato	359	718	
	5	0	8	7	1	1.	5	02/11/92	Ishibai et al.	359	719	
	5	0	4	4	7	0	6	09/03/91	Chen	359	357	
	5	0	4	2	9	3	5	08/27/91	Logan et al.	351	159	
	4	5	9	2	6	8	4	06/03/86	Baker	409	132	
	4	4	4	9	7	9	2	05/22/84	Arai et al.	350	432	
	4	3	9	1	5	1	1	07/05/83	Akiyama et al.	355	40	
\	4	1	8	4	2	9	2	01/22/80	DeFazio et al.	51	235	

Examiner

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			9/1	110	/)	
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Photonics Design and Applications Handbook, 1996, pp. H-487-H-490.

P.R. Hall, "The Use of Aspheric Surfaces in Lens Design", pp. 3-1DM-3-8DM.

^{*} Examiner: Initial citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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